

	Type	L #	Hits	Search Text	DBs	Time Stamp	Comments
1	BRS	L1	1	5491604.pn. and metal	USPA T	2002/11/1 4 09:45	
2	BRS	L2	1	5491604.pn. and polysilicon	USPA T	2002/11/1 4 09:05	
3	BRS	L3	0	5491604.pn. and SEG	USPA T	2002/11/1 4 09:05	
4	BRS	L4	1	6204737.pn. and metal	USPA T	2002/11/1 4 09:15	
5	BRS	L5	2	(mems or microelectromechanical or micromechanical or microdevice or microactuator) and metal\$4 adj2 plate\$1 adj2 electrode\$1	USPA T	2002/11/1 4 09:26	
6	BRS	L6	172	metal\$3 adj1 plate adj1 electrode\$1	USPA T	2002/11/1 4 09:18	
7	BRS	L7	14	(mems or microelectromechanical or micromechanical or microdevice or microactuator) and polysilicon adj1 (resonator or vibrat\$3 or oscillat\$3)	USPA T	2002/11/1 4 09:46	
8	BRS	L8	1	5491604.pn. and flex\$4	USPA T	2002/11/1 4 09:39	
9	BRS	L9	0	5491604.pn. and bend\$3	USPA T	2002/11/1 4 09:39	
10	BRS	L10	26	(mems or microelectromechanical or micromechanical or microdevice or microactuator) and polysilicon adj1 electrode\$1	USPA T	2002/11/1 4 09:58	
11	BRS	L11	0	(mems or microelectromechanical or micromechanical or microdevice or microactuator) and SEG adj2 electrode\$1	USPA T	2002/11/1 4 09:54	
12	BRS	L12	0	SEG adj1 grown adj1 electrode\$1	USPA T	2002/11/1 4 09:54	
13	BRS	L13	3030	SEG\$ adj2 electrode\$1	USPA T	2002/11/1 4 09:57	
14	BRS	L14	0	seg-grown	USPA T	2002/11/1 4 09:57	

	Type	L #	Hits	Search Text	DBs	Time Stamp	Comments
15	BRS	L15	1	(mems or microelectromechanical or microdevice or microactuator) and epitaxially adj1 grown adj1 electrode\$1	USPA T	2002/11/1 4 09:58	